## Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination
10/774,039	MIKULA, MITCHELL B.
Examiner	Art Unit
Le Nguyen	2174

SEARCHED					
Class	Subclass	Date	Examiner		
715	734	9/17/2007	LVN		
		i			
	·				

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
			<i></i>	
	b, USPAT: /734	9/17/2007	LVN	

SEARCH NO (INCLUDING SEARCH		)
	DATE	EXMR
confirmed allowance w/Ba Huynh	9/14/2007	LVN
IEEE Xplore; ACM Digital Library	9/14/2007	LVN
EPO, JPO	9/17/2007	LVN
US-PGPub, USPAT: 715/734,738; 707/200; 711/114	9/17/2007	LVN
		-
<del>-</del> .		